



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
David W. SHERRER et al ) Group Art Unit: 1772  
Application No: 09/519,165 ) Examiner: William P. Watkins, III  
Filed: March 6, 2000 ) Confirmation No: 8879  
FOR: SINGLE MASK LITHOGRAPHIC )  
PROCESS FOR PATTERNING )  
MULTIPLE TYPES OF SURFACE )  
FEATURES )

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to the Official Action mailed January 13, 2004, applicants submit the following amendments and remarks.

**Amendments to the claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.